



FAILURE ANALYSIS OF BRITTLE POLYCRISTALLINE SOLIDS



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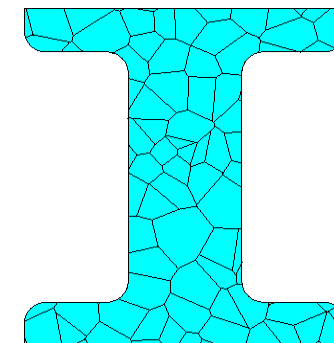
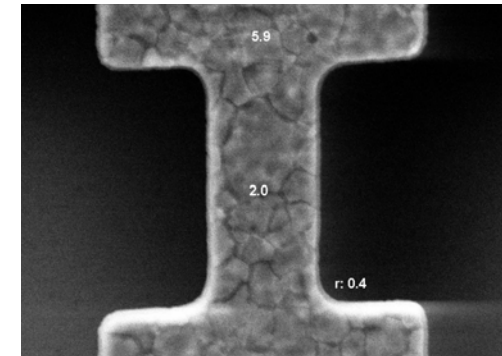
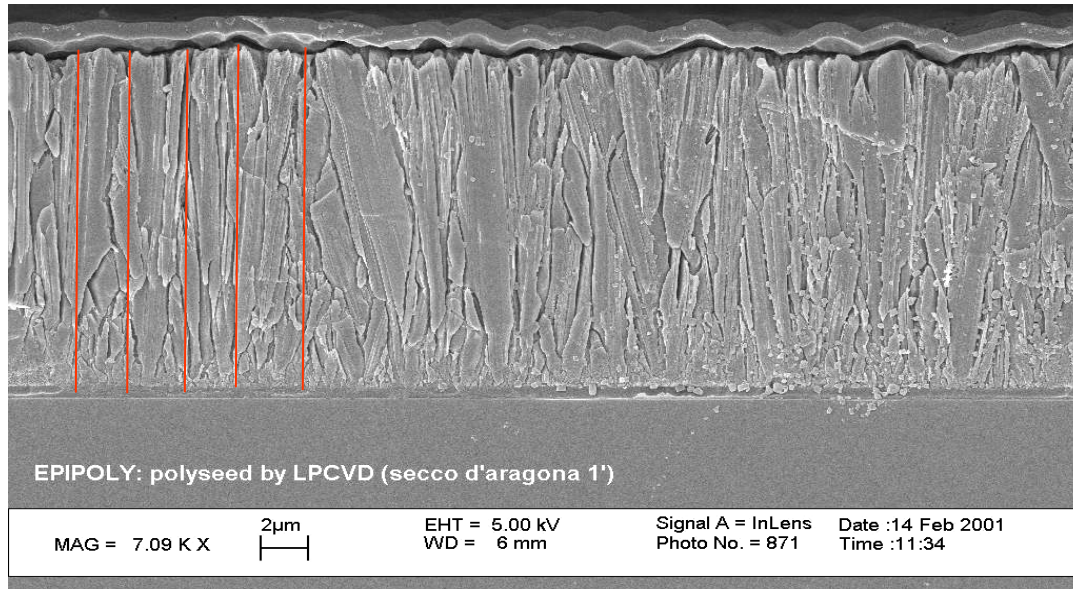
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Il Riunione Gruppo Materiali AIMETA, Genova, 29 febbraio-1 marzo 2008

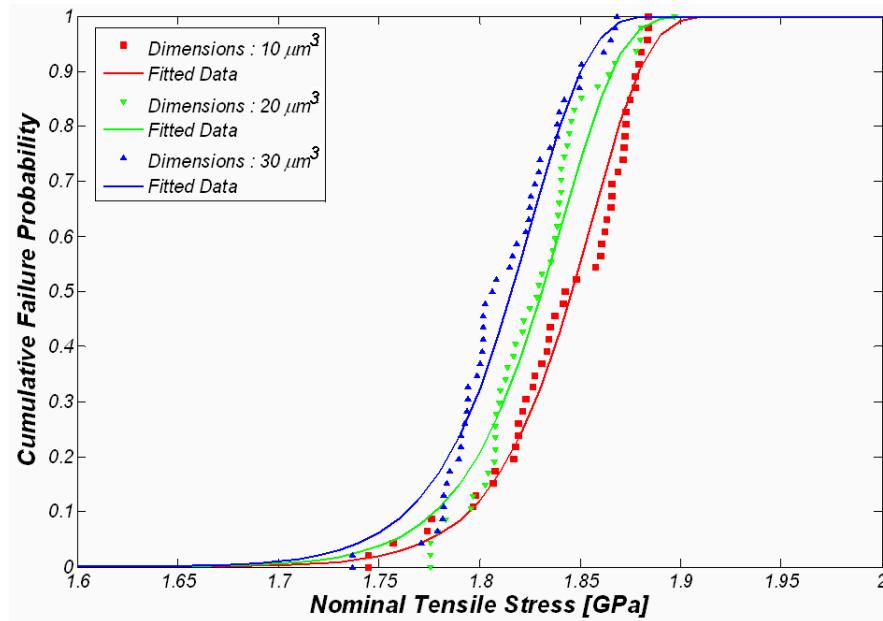
Polysilicon is characterized by an aggregate of crystal grains.

Elastic and fracture properties are influenced by several factors (grain size, grain shape, grain orientation, grain boundary defects,...).

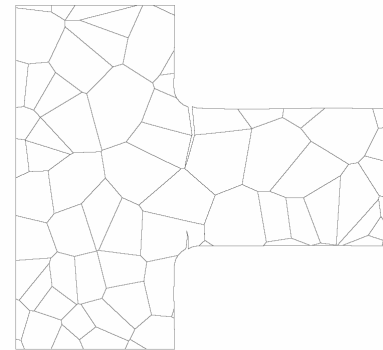
To study MEMS load (shock) carrying-capacity the microstructure has to be taken into account.



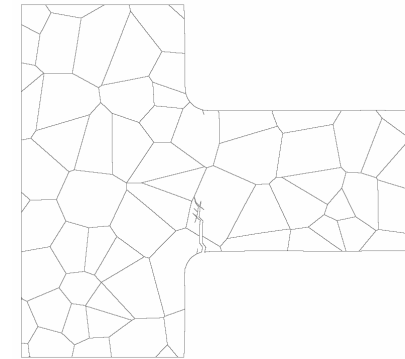
Influence of specimen size on failure probability.



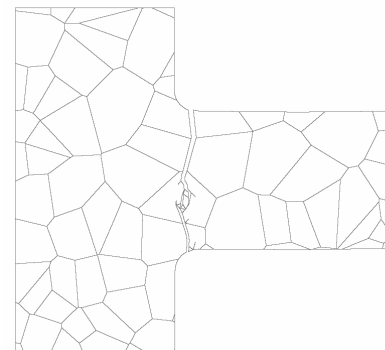
Effects of microstructure on failure.



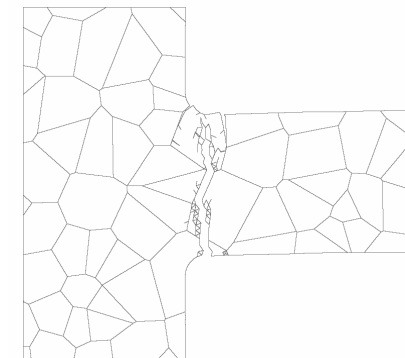
Microstructure A, crack initiation.



Microstructure B, crack initiation.

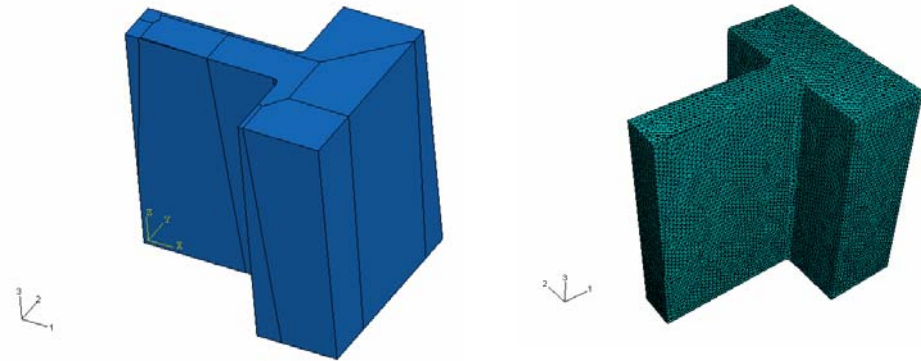


Microstructure A, failure.



Microstructure B, failure.

- 3D simulation of MEMS failure.



- Experimental characterization of polysilicon strength and toughness.
- Effect of anisotropic grain fracture properties on MEMS failure.
- New cohesive constitutive models for grain boundaries.

